

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Mitsuru ISHIKAWA et al.)	Group Art Unit: 1792
)	
Application No.: 09/696,232)	Examiner: Allan W. Olsen
)	
Filed: October 26, 2000)	Confirmation No.: 5127
)	
For: ETCHING METHOD)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL REQUEST FOR RECONSIDERATION

In reply to the Office Communication dated October 20, 2008, the period for response to which extends through November 20, 2008, and the Office Action mailed March 31, 2008, Applicants respectfully request reconsideration of the application in light of the following remarks:

Remarks/Arguments begin on page 2 of this paper.